<u>.</u>	UTILITY
	PATENT APPLICATION
Only	TRANSMITTAL for new nonprovisional applications under 37 CFR 1.53(b)

210608US2 Attorney Docket No.

First Inventor or Application Identifier

Assignee Address:

Tsutomu CH APPARATUS, METHOD, PROGRAM, AND DATA STRUCTURE FOR ASSISTING PLACING ORDER FOR MANUFACTURING SEMICONDUCTOR DEVICE

Assignee Name: KABUSHIKI KAISHA TOSHIBA

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								<u> </u>
See Mi	APPLICATION ELE PEP chapter 600 concerning utility		ADDF	RES	SS TO:	Assistant Commissi Box Patent Applicat Washington, DC 20	ioner for Patents tion 231	3103 09
1. ■ Fe	ee Transmittal Form (e.g. Pl ubmit an original and a duplicate fo	ΓΟ/SB/17) r fee processing)			ACCO	MPANYING APPLIC	ATION PARTS	**
Sp 21051	oecification	Total Sheets 28	8.	•	Applicati	ent Papers (cover shon Data Sheet. See R. §3.73(b) Statemen e is an assignee)	37 CFR 1.76	•
= -	rawing(s) (35 U.S.C. 113)	Total Sheets Formals	10. 1			Translation Documer	nt (if applicable) Copies of I	D.C.
P	ath or Declaration Newly executed (original)		1		Stateme Prelimina White Ad	ion Disclosure nt (IDS)/PTO-1449 ary Amendment dvance Serial No. Po	■ Citations (1	
b. □	i. DELETION OF INV	w/ box 17 completed)	14. I 15. I			Copy of Priority Doc priority is claimed) at claims small entity R 1.27		
Pro Ni (if a. D. Sp	D-ROM or CD-R in duplicate rogram (<i>Appendix</i>) ucleotide and/or Amino Acid applicable, all necessary) Computer Readable Fornoecification or Sequence Lis i. CD-ROM or CD-R (ii. Paper	I Sequence Submission n (CRF) sting on: (2 copies); or	16. 		Other:	Notice of Priority, S	Statement of Relev	rancy
ior a	CONTINUING APPLICATION Division Divisio	nal Continuation- xaminer: hly: The entire disclosure of the prication or divisional application and is	in-pari or application	t (C	CIP)	of prior application n Group Art Ui	nit: is supplied under Box 4	lb, is ed upon
□ This a of app □ Which	18. Amend the specification by inserting before the first line the sentence: ☐ This application is a ☐ Continuation ☐ Division ☐ Continuation-in-part (CIP) ☐ of application Serial No. Filed on ☐ Which was published in English ☐ Which was not published in English							
□ This a	□ This application claims priority of provisional application Serial No. Filed							
•	19. CORRESPONDENCE ADDRESS							



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Name:	Marvin J. Spivak	Registration No.:	24,913
Signature:	Comm Werthy L	Date:	6/29/01
Name:	C. Irvin McC'elland	Registration No.:	

Docket No.

210608US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Tsutomu CHIBA

SERIAL NO:

New Application

FILING DATE: Herewith

FOR:

APPARATUS, METHOD, PROGRAM, AND DATA STRUCTURE FOR ASSISTING PLACING ORDER

FOR MANUFACTURING SEMICONDUCTOR DEVICE

FEE TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS		
TOTAL CLAIMS	23 - 20 =	3	× \$18 =	\$54.00		
INDEPENDENT CLAIMS	5 3 =	2	× \$80 =	\$160.00		
□ MULTIPLE DEPENDE	\$0.00					
□ LATE FILING OF DEC	□ LATE FILING OF DECLARATION + \$1					
	\$710.00					
	\$924.00					
□ REDUCTION BY 50% I	\$0.00					
□ FILING IN NON-ENGL	+ \$130 =	\$0.00				
□ RECORDATION OF AS	+ \$40 =	\$0.00				
	TOTAL					

Please charge Deposit Account No. 15-0030 in the amount of

A duplicate copy of this sheet is enclosed.

A check in the amount of

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6/29/01

to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tsutomu CHIBA

GAU:

EXAMINER:

FILED:

HEREWITH

SERIAL NO: NEW APPLICATION

FOR:

APPARATUS, METHOD, PROGRAM, AND DATA STRUCTURE FOR ASSISTING PLACING ORDER

FOR MANUFACTURING SEMICONDUCTOR DEVICE

REQUEST FOR PRIORITY

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

- ☐ Full benefit of the filing date of U.S. Application Serial Number, filed, is claimed pursuant to the provisions of 35 U.S.C. §120.
- ☐ Full benefit of the filing date of U.S. Provisional Application Serial Number, filed, is claimed pursuant to the provisions of 35 U.S.C. §119(e).
- Applicants claim any right to priority from any earlier filed applications to which they may be entitled pursuant to the provisions of 35 U.S.C. §119, as noted below.

In the matter of the above-identified application for patent, notice is hereby given that the applicants claim as priority:

CO	U	N	Т	R	Y

APPLICATION NUMBER

MONTH/DAY/YEAR

JAPAN

2000-199372

June 30, 2000

Certified copies of the corresponding Convention Application(s)

- are submitted herewith
- will be submitted prior to payment of the Final Fee
- were filed in prior application Serial No. filed
- were submitted to the International Bureau in PCT Application Number. Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304.
- ☐ (A) Application Serial No.(s) were filed in prior application Serial No. filed; and
 - (B) Application Serial No.(s)
 - are submitted herewith
 - will be submitted prior to payment of the Final Fee

Respectfully Submitted,

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